

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/632,069	CHAUVEL ET AL.	
Examiner	Art Unit	
Jacob Petranek	2183	

	SEARCHED				
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST Search	6/20/2007	JP		
712/209,213, 229 - text search only	6/20/2007	JP		
Consulted Dave Huisman	6/19/2007	JP		
Consulted Richard Ellis	6/19/2007	JP		
Consulted Aimee Li	6/18/2007	JP		
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